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 Application/Control No.	Applicant(s)/Patent under Reexamination						
09/975,801	AGRAWAL ET AL.						
Examiner	Art Unit	-					
Jung Park	2661						

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Class	Subclass	Date	Examiner
370	331, 338, 349, 352, 401, 329	7/22/2005	JР
370	473	7/22/2005	JP
455	442, 436	7/22/2005	JP

INTERFERENCE SEARCHED						
Class	Subclass	Date	Examiner			
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SEARCH NOTES (INCLUDING SEARCH STRATEGY)					
	DATE	EXMR			
Chau Nguyen suggesd 370/331, 338, 401	7/22/2005	JP			
Searched IEEE.	7/23/2005	JP			